
**Preparation of silicon carbide and
similar materials for analysis by ISO
12677 X-ray fluorescence (XRF) —
Fused cast-bead method**

*Préparation du carbure de silicium et de matériaux similaires en vue
d'une analyse par fluorescence de rayons X (FRX) selon l'ISO 12677 —
Méthode de la perle fondue*



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ISO copyright office
CP 401 • Ch. de Blandonnet 8
CH-1214 Vernier, Geneva
Phone: +41 22 749 01 11
Fax: +41 22 749 09 47
Email: copyright@iso.org
Website: www.iso.org

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

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Preparation of silicon carbide and similar materials for analysis by ISO 12677 X-ray fluorescence (XRF) — Fused cast-bead method

1 Scope

This document specifies requirements for the preparation of fused beads for the chemical analysis of silicon carbide containing samples using X-ray fluorescence (XRF). The test methods described in this document are for silicon carbide and silicon carbide materials; however, the principles described can be applied to other reduced materials such as boron carbide, boron nitride, ferroalloys, sialons and silicon nitride using the modifications given in [Annex A](#).

Fused cast beads of the samples prepared in accordance with this document are analysed in accordance with ISO 12677.

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

ISO 12677:2011, *Chemical analysis of refractory products by X-ray fluorescence (XRF) — Fused cast-bead method*

ISO 21068-1, *Chemical analysis of silicon-carbide-containing raw materials and refractory products — Part 1: General information and sample preparation*

ISO 21068-2, *Chemical analysis of silicon-carbide-containing raw materials and refractory products — Part 2: Determination of loss on ignition, total carbon, free carbon and silicon carbide, total and free silica and total and free silicon*

ISO 8656-1, *Refractory products — Sampling of raw materials and unshaped products — Part 1: Sampling scheme*

3 Terms and definitions

No terms and definitions are listed in this document.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at <https://www.iso.org/obp>
- IEC Electropedia: available at <http://www.electropedia.org/>

4 General considerations

Silicon carbides and non-oxide materials in general pose special problems in preparation and analysis.

These materials act exothermically on fusion and can easily react with the platinum alloy fusion dishes that are used to contain the reaction. In order to prevent this occurring, either some way of keeping the reaction from the dishes (using two fluxes, one to produce a protective layer and the other to react with the sample) or a different type of flux altogether is required. Sometimes a catalyst such as V₂O₅ might